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PATENT APPLICATION *RCE*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Masaru MITSUI

Group Art Unit: 1795

Application No.: 10/523,470

Examiner: R. MCDONALD

Filed: March 10, 2005

Docket No.: 122672

For: METHOD FOR MANUFACTURING MASK
BLANK, METHOD FOR MANUFACTURING
TRANSFER MASK, SPUTTERING TARGET
FOR MANUFACTURING MASK BLANK

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)
continued examination.

☒ Applicant(s) further request(s) entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 231846 in the amount of ☒ \$810.00 as payment of the fees
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees
or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Tommy T. Kim
Registration No. L0543

JAO:TTK/eks

Date: September 9, 2010

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry of this filing;
Charge any fee due to our
Deposit Account No. 15-0461